



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

24 / Amdt
7106-03
A. Wach

In re application of

Docket No: Q54431

Toshiro HAYAKAWA, et al.

Application No.: 09/315,068

Group Art Unit: 2828

Confirmation No.: 5982

Examiner: Jeffrey N. Zahn

Filed: May 20, 1999

For: SEMICONDUCTOR LASER AND METHOD OF MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 23, 2003, please amend the above-identified application as follows on the accompanying pages.

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